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1	6,339,527	01/2002	Farooq et al.	36/	3	*							
2	6,277,436	08/2001	Stauf et al.	427	126-3	<i>(</i>							
3	5,822,175	10/1998	Azuma, Masamichi	361	321.5								
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5	5,185,689	02/1993	Maniar, Papu D.	367	7/3								
6	6,660,535	12/2003	Basceri et al.	438	3	X							
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FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. MICRON.098CDV2	APPLICATION NO Unknown
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MB	3	5,506,166	4/9/96	Sandhu et al.	438	396	
WB:	4	5,717,234	2/10/98	Si et al.	257	295	7
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